Title: METHOD FOR PREDICTING PRECIPITATION BEHAVIOR OF OXYGEN IN SILICON SINGLE CRYSTAL, METHOD FOR DETERMINING PRODUCTION PARAMETER OF SILICON SINGLE CRYSTAL, AND STORAGE MEDIUM FOR STORING PROGRAM FOR PREDICTING PRECIPITATION BEHAVIOR OF OXYGEN IN SILICON SINGLE CRYSTAL. (KOZO NAKAMURA, JUNSUKE TOMIOKA, TETSURO AKAGI, SHIRO YOSHINO) Attorney Docket No.: 1110/97825 Filed: 7/17/2006 (SHEET 1 OF 6)

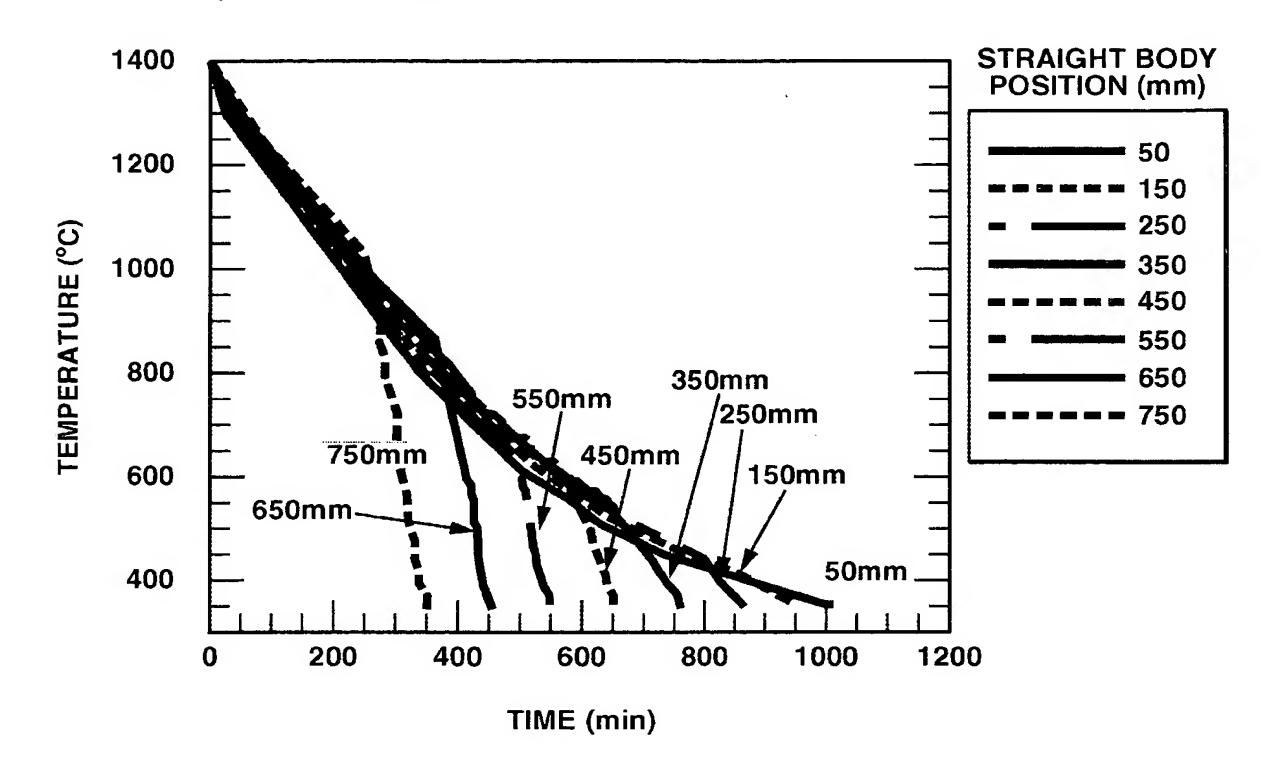


FIG.1

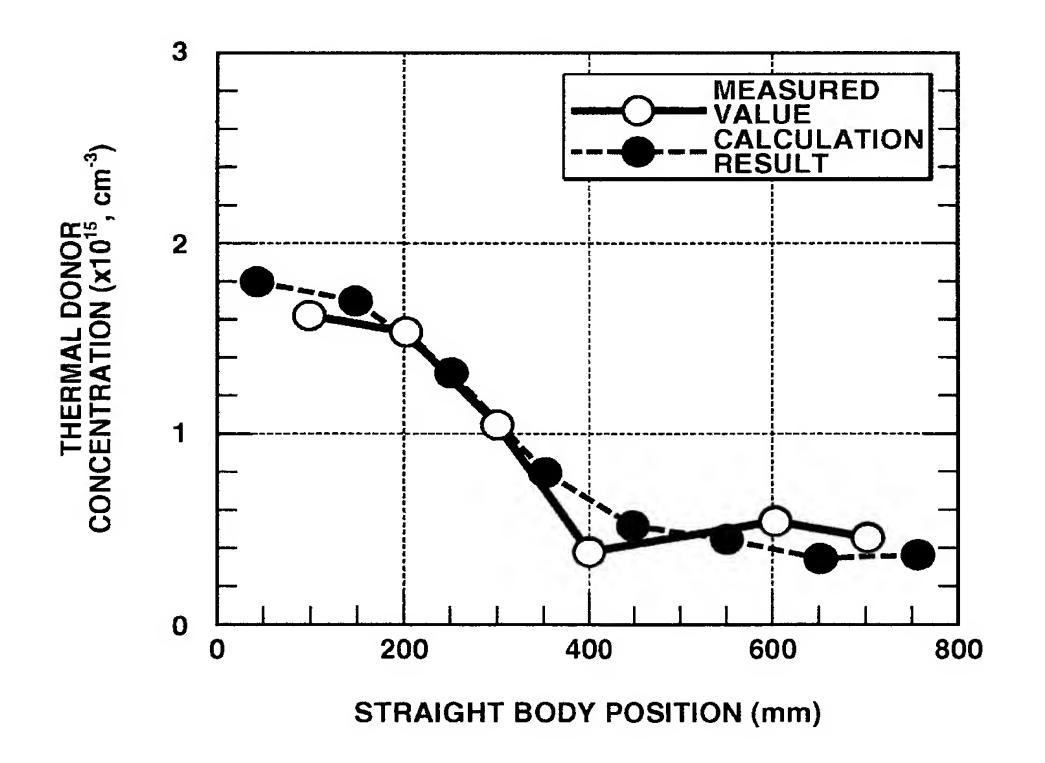


FIG.2

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Title: METHOD FOR PREDICTING PRECIPITATION BEHAVIOR OF OXYGEN IN SILICON SINGLE CRYSTAL, METHOD FOR DETERMINING PRODUCTION PARAMETER OF SILICON SINGLE CRYSTAL, AND STORAGE MEDIUM FOR STORING PROGRAM FOR PREDICTING PRECIPITATION BEHAVIOR OF OXYGEN IN SILICON SINGLE CRYSTAL. (KOZO NAKAMURA, JUNSUKE TOMIOKA, TETSURO AKAGI, SHIRO YOSHINO) Attorney Docket No.: 1110/97825 Filed: 7/17/2006 (SHEET 2 OF 6)

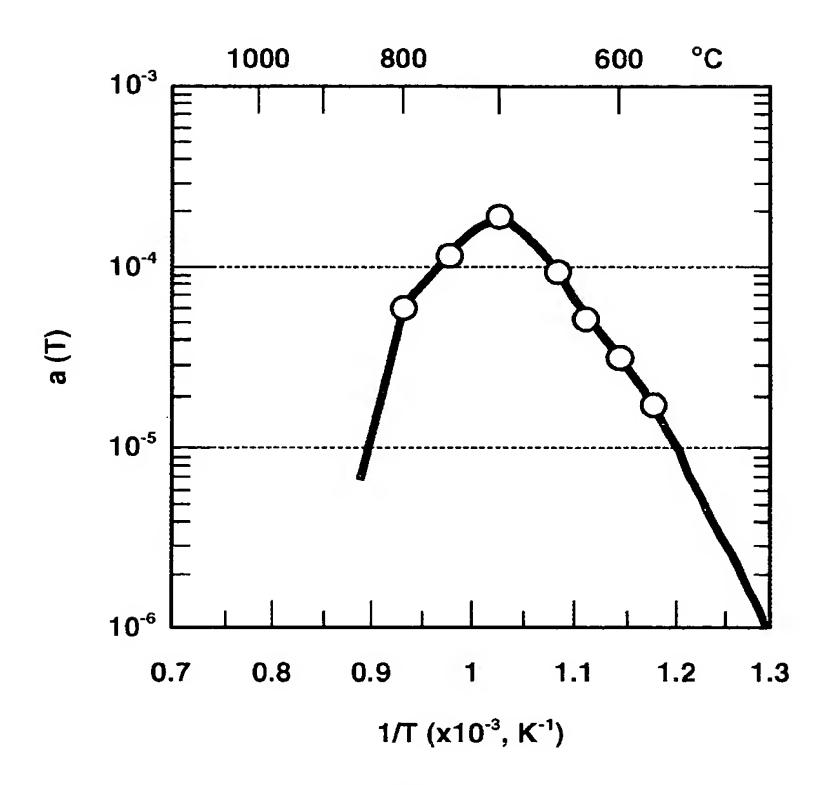


FIG.3

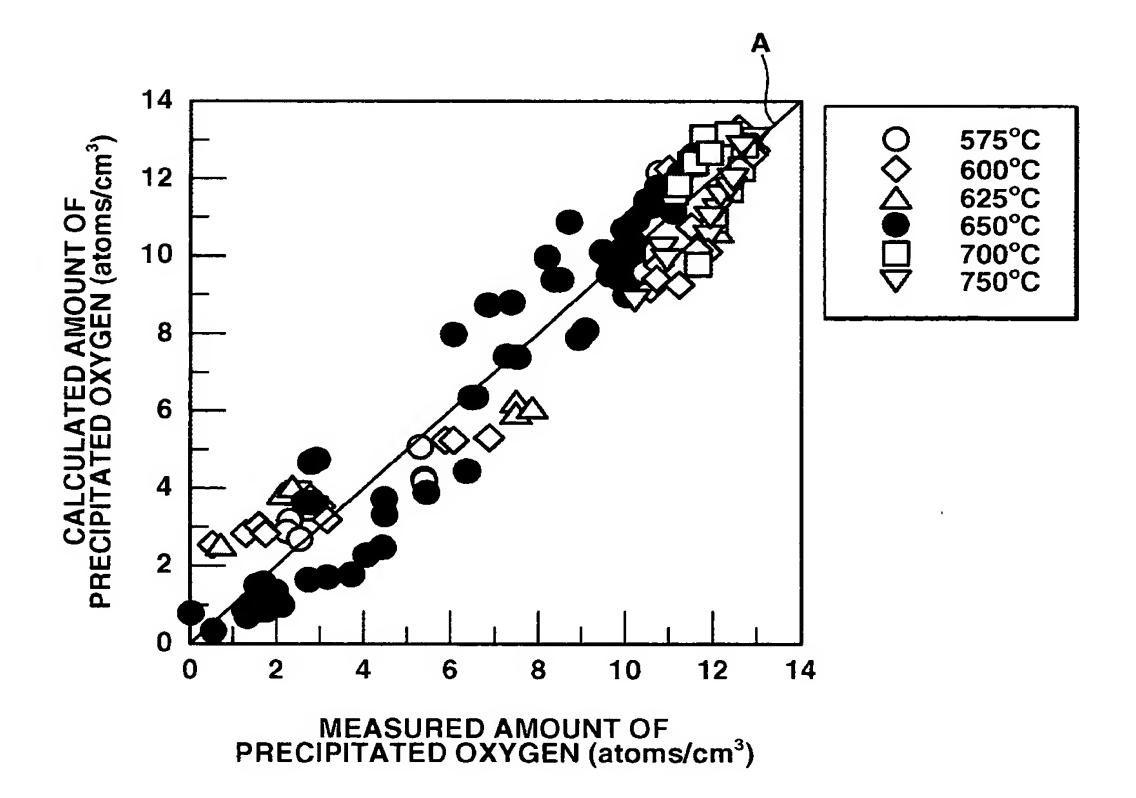


FIG.4

Title: METHOD FOR PREDICTING PRECIPITATION BEHAVIOR OF OXYGEN IN SILICON SINGLE CRYSTAL, METHOD FOR DETERMINING PRODUCTION PARAMETER OF SILICON SINGLE CRYSTAL, AND STORAGE MEDIUM FOR STORING PROGRAM FOR PREDICTING PRECIPITATION BEHAVIOR OF OXYGEN IN SILICON SINGLE CRYSTAL. (KOZO NAKAMURA, JUNSUKE TOMIOKA, TETSURO AKAGI, SHIRO YOSHINO) Attorney Docket No.: 1110/97825 Filed: 7/17/2006 (SHEET 3 OF 6)

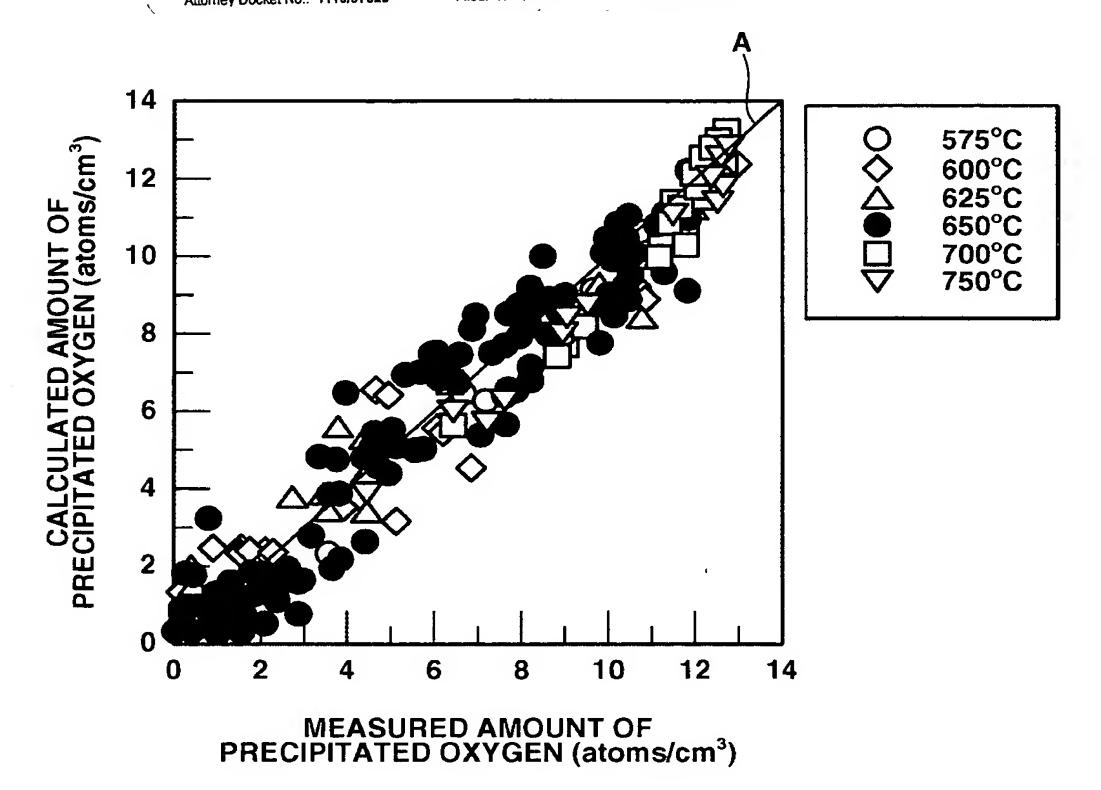


FIG.5

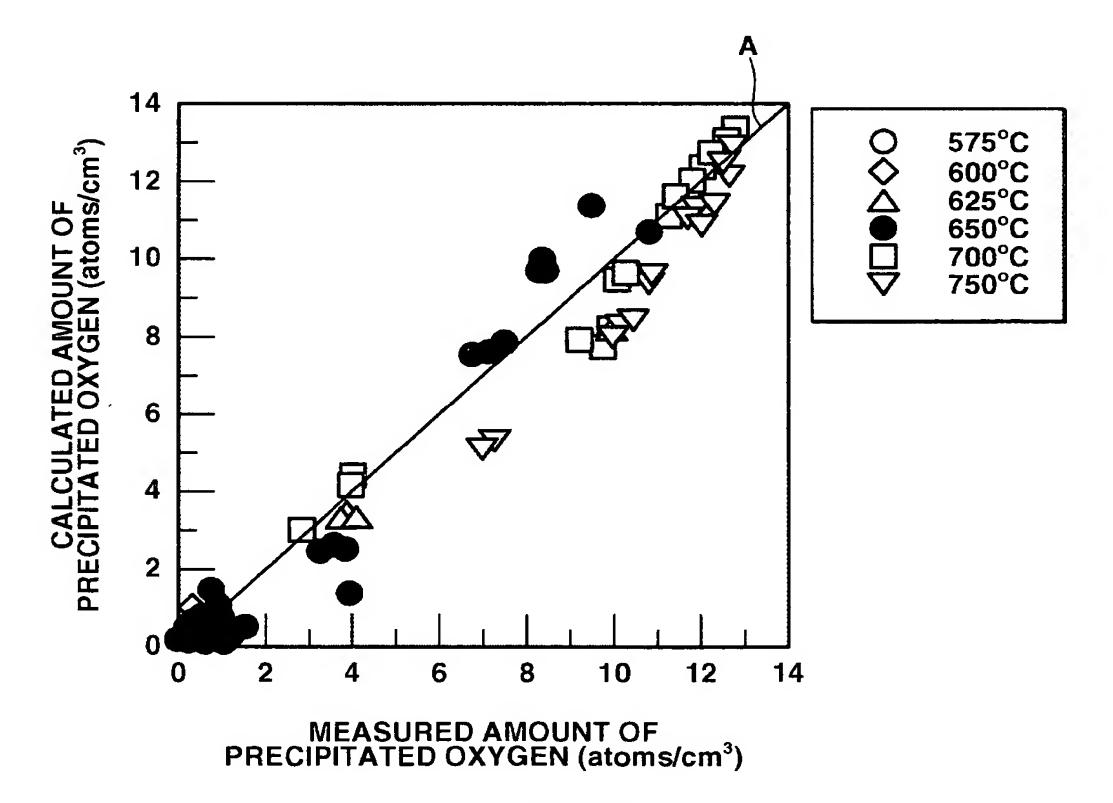


FIG.6

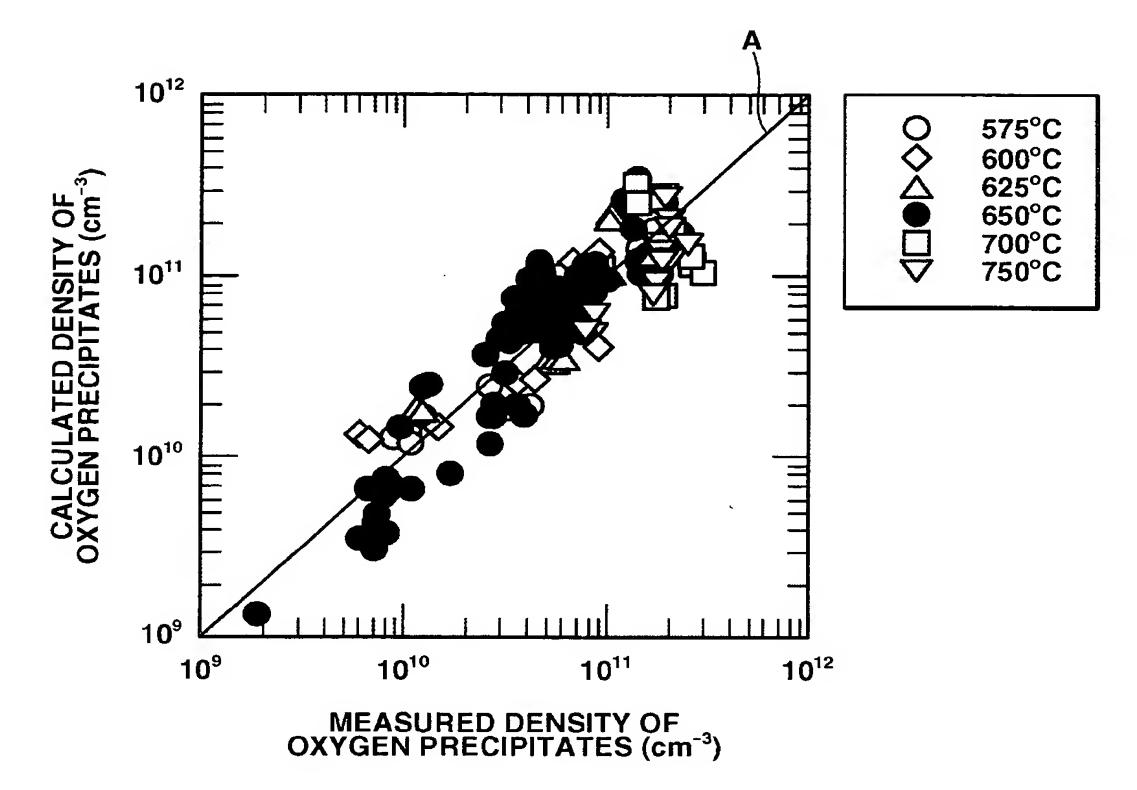


FIG.7

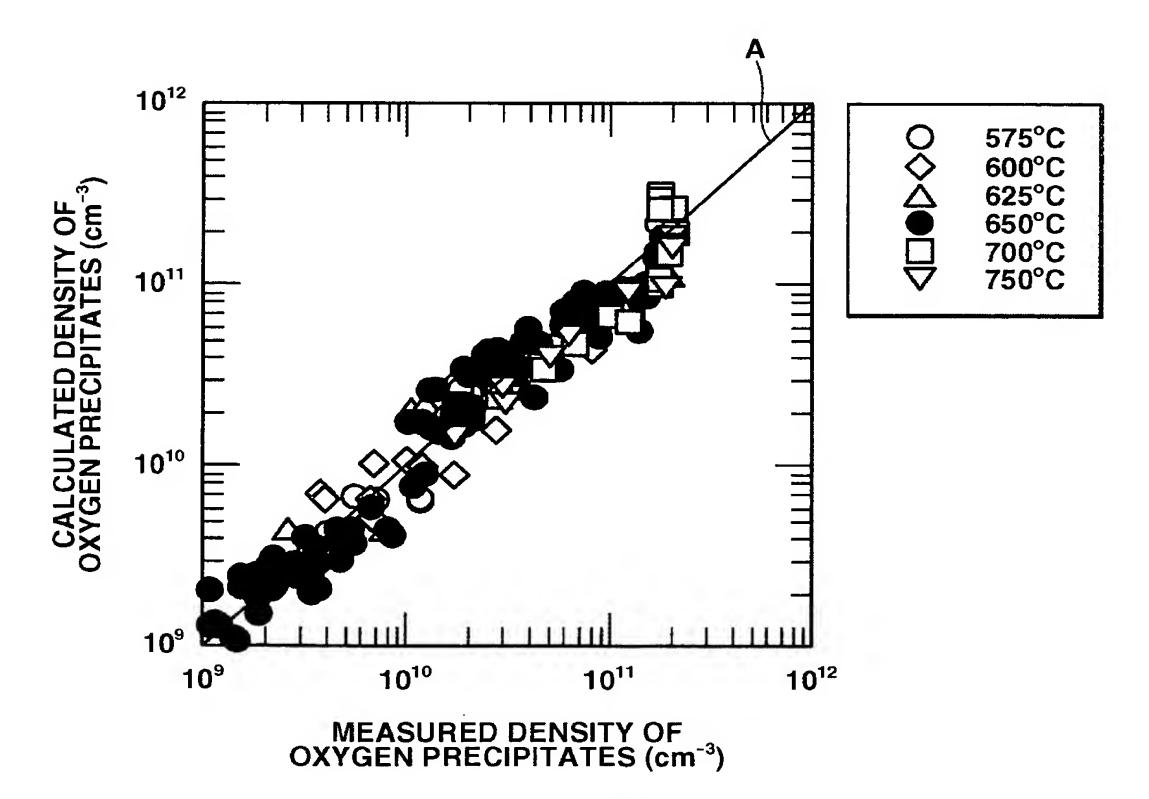


FIG.8

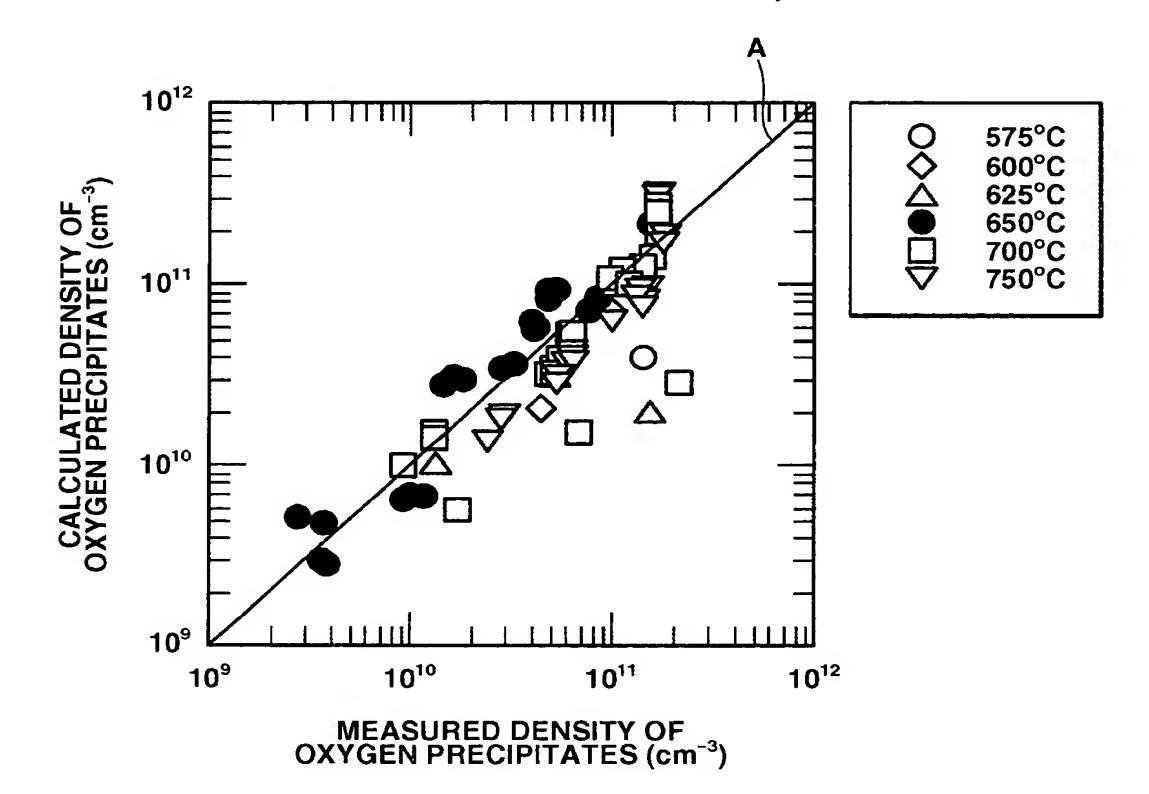


FIG.9

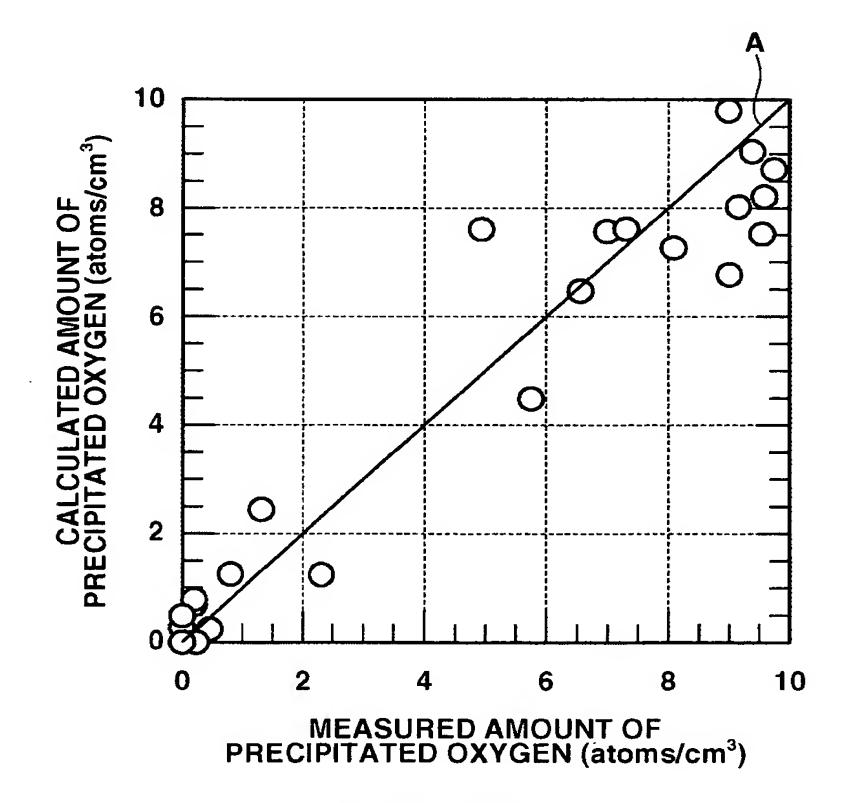


FIG.10

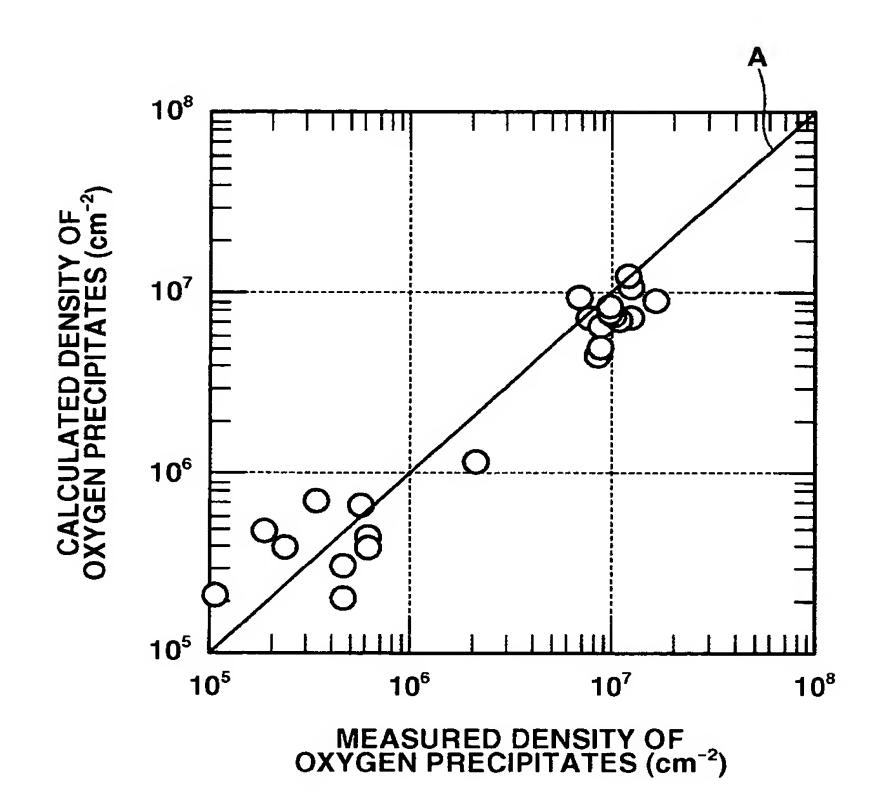


FIG.11